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PATENT  
5589-05201/P1067

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Lange

Serial No. 10/725,744

Filed: December 2, 2003

For: SYSTEMS FOR INSPECTING  
WAFERS AND RETICLES WITH  
INCREASED RESOLUTION

Group Art Unit: 2877  
Examiner: Stafira, Michael Patrick

Atty. Dkt. No. 5589-05201 P1067

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1-12-06  
Date

Pamela Gerik  
Pamela Gerik

AMENDMENT; RESPONSE TO OFFICE ACTION MAILED OCTOBER 20, 2005

MS: Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir/Madam:

This paper is submitted in response to the Office Action mailed October 20, 2005 to  
further highlight reasons why the application is in condition for allowance.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this  
paper.

Remarks begin on page 5 of this paper.